

Notice of References Cited	Application/Control No. 10/591,919		Applicant(s)/Patent Under Reexamination TANIGUCHI ET AL.	
	Examiner REBECCA LEE		Art Unit 1793	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,423,426 B1	07-2002	Kobayashi et al.	428/659
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Machine translation of JP2003239040
	V	Machine translation of JP06108152
	W	Machine translation of JP05331537
	X	

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